



520.39649CX3

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: MASUDA et al  
Serial No.: 10/810,598  
Filed: March 29, 2004  
For: Plasma Processing System And A Sample Processing Method  
Art Unit: 1763  
Examiner: P. Hassanzadeh

**AMENDMENT**

Mail Stop: Amendment (Fee)  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 24, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated September 24, 2004. The amendments are listed below and set forth on the following pages.

Amendments to the Specification:

Amendments to the Claims;

Amendments to the Drawings describing changes to drawing shown in the

Appendix;

Remarks are included following the amendments; and

An Appendix including amended drawing figures is attached following the

Remarks.

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04 FC:1202

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150.00 DP